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JC06 Rec'd PCT/PTO 18 MAR 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Susumu HORITA, et al.**

Serial Number: **Not Yet Assigned**
(§371 of International Application PCT/JP03/11988)

Filed: **March 18, 2005**

For: **METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE AND
SUBSTRATE PROCESSING APPARATUS**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 18, 2005

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449 and cited in the enclosed international search report.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 01-2340.

Respectfully submitted,

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PATENT TRADEMARK OFFICE

Enclosures: PTO-1449; International Search Report

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INFORMATION DISCLOSURE STATEMENT PTO-1449	Atty. Docket No. 050169	Serial No. New Application
	Applicant(s): Susumu HORITA, et al.	
	Filing Date: March 18, 2005	Group Art Unit: Not Yet Assigned

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA	5,693,578	T. Nakanishi, et al.	12/02/97			
_____	AB						
_____	AC						
_____	AD						

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Translation (Yes or No)
_____	AE	1-239933	09/25/89	Japan	Cited in the International Search Report
_____	AF	5-29307	02/05/93	Japan	Cited in the International Search Report
_____	AG				
_____	AH				
_____	AI				

OTHER DOCUMENTS

_____	AJ			
_____	AK			
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